# Supporting Information for "Simultaneously Efficient Light <br> Absorption and Charge Separation in $\mathrm{WO}_{3} / \mathrm{BiVO}_{4}$ Core/Shell Nanowire Photoanode for Photoelectrochemical Water Oxidation" 

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Figure S 1 . Quantification of the W -doping concentration in the $\mathrm{W}: \mathrm{BiVO}_{4}$ shell of $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4}$ NWs by X-ray diffraction (XRD). As W is doped into $\mathrm{BiVO}_{4}$, the $\mathrm{BiVO}_{4}$ crystal structure becomes distorted. ${ }^{1}$ The extent of this distortion is used to estimate the W -doping level in the $\mathrm{W}: \mathrm{BiVO}_{4}$ shell of the $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4} \mathrm{NWs}$ by comparison of the XRD pattern of the NWs with those of $\mathrm{BiVO}_{4}$ films prepared with known W-doping levels. (a) The XRD pattern of the $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4} \mathrm{NWs}$ is compared to those of pure, $3 \%$ and $7 \% \mathrm{~W}$-doped $\mathrm{BiVO}_{4}$ films. Consistent with previous reports, ${ }^{1-4}$ for the (200) and (002) peaks of undistorted $\mathrm{BiVO}_{4}$ at $2 \theta=$ 34.5 and $35.2^{\circ}$, denoted by the left arrow in (a) and enlarged in (b), and the (240) and (024) peaks of undistorted $\mathrm{BiVO}_{4}$ at $2 \theta=46.7$ and $47.3^{\circ}$, denoted by the right arrow in (a) and enlarged in (c), both converge to form single peaks when the W -doping is $7 \%$, while separate peaks are clearly distinguishable even at $3 \%$ doping. Since the peaks in the $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4} \mathrm{NWs}$ have nearly converged, the average W -doping level in the $\mathrm{BiVO}_{4}$ shell is estimated to be about $7 \%$. The peak indicated by an arrow in (c) is due to $\mathrm{WO}_{3}$.


Figure S2. Scanning Electron Microscope (SEM) images of samples synthesized in this work. Left: side view, Right: top view of $\mathrm{WO}_{3}$ nanowires ( NWs ), $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4}$ core/shell NWs and $7 \mathrm{at} \% \mathrm{~W}: \mathrm{BiVO}_{4}$ film (containing the same mass of Bi as coated onto the $\mathrm{WO}_{3} \mathrm{NWs}$ ). The scale bar applies to all images in the panel.


Figure S3. Histogram of diameters of the bare $\mathrm{WO}_{3} \mathrm{NWs}$ and the $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4}$ core/shell NWs. The bare $\mathrm{WO}_{3} \mathrm{NWs}$ have a 75 nm average diameter and the average $\mathrm{W}: \mathrm{BiVO}_{4}$ shell thickness is 60 nm .


Figure S4. Spectral output of illumination sources used in this work. (a) Spectral irradiance of the class-AAA Solar Simulator ( $85 \mathrm{~mW} / \mathrm{cm}^{2}$ overall intensity) used to measure current-voltage ( $J-V$ ) curves, measured with a calibrated spectroradiometer, compared to the air mass 1.5 global (AM 1.5G, ASTM-G173-3) standard. For both the simulated illumination and the AM 1.5G standard, the integrated photon current up to a wavelength of 515 nm (the band gap of $\mathrm{BiVO}_{4}$ ) corresponds to a photocurrent of $7.5 \mathrm{~mA} / \mathrm{cm}^{2}$, thereby indicating that the simulated sunlight is an accurate representation of the standard. (b) Irradiance of Xe lamp with monochromator, used for incident photon-to-current conversion efficiency (IPCE) measurements, measured with a calibrated silicon photodiode.


Figure S5. Reflectance of the $\mathrm{WO}_{3} / \mathrm{W}: \mathrm{BiVO}_{4}$ core/shell NWs and the 7 at $\% \mathrm{~W}: \mathrm{BiVO}_{4}$ film (containing the same mass of Bi as coated onto the $\mathrm{WO}_{3} \mathrm{NWs}$ ).


Figure S6. Measurement of conductance of single $\mathrm{WO}_{3} \mathrm{NWs}. \mathrm{WO}_{3} \mathrm{NWs}$ were removed from the growth substrate by sonication in IPA and then drop-casted onto a $\mathrm{SiO}_{2} / \mathrm{Si}$ substrate, after which Pt contacts were deposited on both ends of the $\mathrm{WO}_{3} \mathrm{NW}$ using a focused ion beam (FEI Strata DB235). The current-voltage ( $I-V$ ) measurements were conducted at room temperature using a semiconductor analyzer (Keithley Model 4200-SCS) with tungsten probes. A measured $\mathrm{WO}_{3}$ NW is shown in the SEM inset ( $52^{\circ}$ tilt). A conductance of $6 \times 10^{-6} \mathrm{~S}$ was calculated based on a current of $6.3 \mu \mathrm{~A}$ at an applied voltage of 1 V , and a conductivity of $5 \mathrm{~S} / \mathrm{cm}$ was calculated based on the NW diameter of 160 nm and length of 1600 nm (corrected for tilt). Since $\mathrm{WO}_{3}$ is an ntype material and the measurement was performed in the dark, this is purely a measure of electron conductivity. The measured conductivity closely matches the conductivity of single crystal monoclinic $\mathrm{WO}_{3} \mathrm{NWs}$ with the same [001] growth direction found by others using conductive atomic force microscopy ( $\sim 1.8 \mathrm{~S} / \mathrm{cm}$ ). ${ }^{5,6}$


Figure S7. The Nyquist plot from the impedance measurement of a $7 \% \mathrm{~W}$-doped $\mathrm{BiVO}_{4}$ film, and the equivalent circuit used to fit the measured data. The AC impedance was measured in the dark at room temperature using a 2-probe setup and an impedance analyzer (Agilent Model 4294A) with an applied potential of 500 mV over the frequency range of 40 Hz to 10 MHz . One probe was attached to the exposed surface of a conductive FTO (fluorine-doped tin oxide) glass sheet coated with a $7 \mathrm{at} \% \mathrm{~W}: \mathrm{BiVO}_{4}$ film. The second probe was connected to a piece of adhesive copper tape (Ted Pella) pressed onto the $\mathrm{W}: \mathrm{BiVO}_{4}$ film. The Nyquist plot shows a broadened arc which can be decomposed into semicircles by means of the equivalent electrical circuit, which consists of three pairs of parallel-connected capacitors and resistors connected in series. Pair \# 1 produces the high-frequency semicircle and is due to the bulk impedance; pair \# 2 produces the middle-frequency semicircle and is due to the grain boundary impedance; and Pair \# 3 produces the low-frequency semicircle and is due to the film/electrode interface impedance. The bulk conductivity was calculated to be $4 \times 10^{-8} \mathrm{~S} / \mathrm{cm}$ from the fitted value of $\mathrm{R}_{1}$ ( 125 ohm ), using the film thickness measured from cross-section SEM images ( 50 nm ), and the area of the copper tape $\left(1 \mathrm{~cm}^{2}\right)$. Since $\mathrm{W}: \mathrm{BiVO}_{4}$ is an n-type material and the measurement was performed in the dark, this is purely a measure of electron conductivity.

## References

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